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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.	:	10/045,766	Confirmation No:	3061
Applicants	:	Tuttle et al.	Art Unit:	2812
Filed	:	10/23/2001	Examiner:	Andre C. Stevenson
Docket No.	:	5000.142		
For	:	PATTERN FOR IMPROVED VISUAL INSPECTION OF SEMICONDUCTOR DEVICES		

May 5, 2004

Commissioner for Patents
Post Office Box 1450
Alexandria, VA 22313-1450

REPLY TO NOTICE OF NON-COMPLIANT AMENDMENT

Sir:

This responds to the Office communication mailed April 26, 2004.

Amendments to the Claims begin on page 2 of this paper.

Remarks and arguments begin on page 10 of this paper.

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